

PATENT

Docket No. 1232-4610



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): K. YANAGITA, et al.

Serial No.: 10/081,068

Group Art Unit: 2812

Filed: February 21, 2002

Examiner: TBA

For: COMPOSITE MEMBER AND SEPARATING METHOD THEREFOR, BONDED  
SUBSTRATE STACK AND SEPARATING METHOD THEREFOR, TRANSFER METHOD  
FOR TRANSFER LAYER, AND SOI SUBSTRATE MANUFACTURING METHOD

STATUS INQUIRY

Mail Stop \_\_\_\_\_  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

As per the above-captioned information, on February 21, 2002 applicant filed the above-identified patent application which was assigned U.S. Patent Application Serial No. 10/081,068. As of the date of this letter, Applicant has not received an Official Action from the Patent and Trademark Office.

Accordingly, the Office is respectfully requested to advise applicant about the status of this application. The Office is urged to telephone undersigned at the number noted below if any further information is needed.

Respectfully submitted,  
MORGAN & FINNEGAN, L.L.P.

Dated: June 22, 2004

By: 

Eric G. Wright

Registration No. 48,045

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June 22, 2004

Mr. Yasunori Ohtsuka  
Ohtsuka Patent Office  
7th F., Shuwa Kioicho Park Bldg.  
3-6, Kioicho, Chiyoda-ku  
Tokyo 102-0094, Japan

Re: U.S. Patent Application Serial No. 10/081,068  
For: *COMPOSITE MEMBER AND SEPARATING METHOD THEREFOR,  
BONDED SUBSTRATE STACK AND SEPARATING METHOD THEREFOR,  
TRANSFER METHOD FOR TRANSFER LAYER, AND SOI SUBSTRATE  
MANUFACTURING METHOD*  
Your Ref: CFM 1814US/P200-0004US  
Our Ref: 1232-4610US1

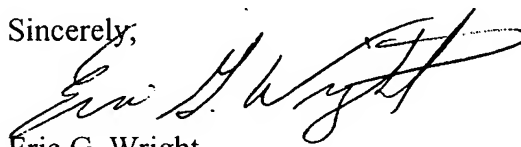
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Dear Mr. Ohtsuka:

We filed a Status Inquiry in the United States Patent & Trademark Office today. Copies of the filing papers are enclosed for your records.

We will keep you apprised of further development in this matter as they occur. If you have any questions, or comments, please do not hesitate to contact us.

Sincerely,



Eric G. Wright

EGW/crp

Enclosures  
cc: Joseph A. Calvaruso